IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No	10/624,716
	July 21, 2003
	Luan C. Tran
Assignee	Micron Technology, Inc.
Group Art Unit	2812
Examiner	
Attorney's Docket No	Ml22-2357
	021567
Title: ,	Methods of Forming Semiconductor Constructions

RESPONSE TO AUGUST 23, 2006 OFFICE ACTION

To:

Mail Stop Amendment Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

From:

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AMENDMENTS

Introductory Comments

In reply to the Office Action of August 23, 2006, applicant amends and remarks as follows.